New Products



FORMTRACER Avant (Surface Texture Measuring Instruments) C3000/4000 Series Refer to page L-10 for details.



FORMTRACER (Surface Texture Measuring Instruments) CS-3300 Series Refer to page L-12 for details.



Roundtest Extreme (CNC Roundness/Cylindricity Measuring System) RA-6000CNC Refer to page L-24 for details.

Form Measurement

Surftest



Contracer



Formtracer



Roundtest



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Surftest

Performs brilliantly in many situations such as in the quality control room, on the factory floor and on the production line.



SPECIFICATIONS

Si Leine/Tions								
		Standard drive unit		Retractable	Retractable drive unit		Transverse tracing drive unit	
Model No.			SJ-210	SJ-210	SJ-210	SJ-210	SJ-210	SJ-210
			(0.75 mN type)	(4 mN type)	(0.75 mN type)	(4 mN type)	(0.75 mN type)	(4 mN type)
Order No.		mm	178-560-11	178-560-12	178-562-11	178-562-12	178-564-11	178-564-12
Urder No.	inch/mm		178-561-11	178-561-12	178-563-11	178-563-12	178-565-11	178-565-12
. X axis		16.0 mm			5.6 mm			
Measuring range	Detector	Range			n)			
range	Delector	Range/Resolution	360 μm/0.02 μm, 100 μm/0.006 μm, 25 μm/0.002 μm					
Measuring force/Stylus tip shape			Depends on the Order No.: 0.75 mN/2 μmR 60° (when the Order No. ends with "-11") 4 mN/5 μmR 90° (when the Order No. ends with "-12")					
Applicable standards			JIS 1982/JIS 1994/JIS 2001/ISO 1997/ANSI/VDA					
Assessed profile			Primary profile, Roughness profile, DF profile, Roughness motif profile					

Surftest SJ-310 SERIES 178 — On-site Surface Roughness Tester

MeasurLink[®] ENABLED

Data Management Software by Mitutoyo



SPECIFICATIONS

Model No.		Standard drive unit		Retractable drive unit		Transverse tracing drive unit		
		SJ-310	SJ-310	SJ-310	SJ-310	SJ-310	SJ-310	
		(0.75 mN type)	(4 mN type)	(0.75 mN type)	(4 mN type)	(0.75 mN type)	(4 mN type)	
Order No.	mm	178-570-11	178-570-12	178-572-11	178-572-12	178-574-11	178-574-12	
Order No.	inch/mm	178-571-11	178-571-12	178-573-11	178-573-12	178-575-11	178-575-12	
Managerian	. X axis		16.0 mm				5.6 mm	
Measuring	Detector Range	360 μm (-200 μm to +160 μm)						
range	Range/Resolution	360 µm/0.02 µm, 100 µm/0.006 µm, 25 µm/0.002 µm						
Measuring	force/Stylus tip shape	Depends on the Order No.: 0.75 mN/2 µmR 60° (when the Order No. ends with "-11") 4 mN/5 µmR 90° (when the Order No. ends with "-12")				s with " -11 ")		
Applicable	standards	JIS 1982/JIS 1994/JIS 2001/ISO 1997/ANSI/VDA						
Assessed p	rofile	Primary profile, Roughness profile, DF profile, Roughness motif profile, Waviness motif profile						

MeasurLink® ENABLED Data Management Software by Mitutoyo

Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).

Compact type all-in-one surface roughness tester has evolved by meeting customer demands

- The color LCD can display not only calculation results and measurement conditions, but also surface roughness waveforms. In addition, bigger character size contributes to visibility.
- Built-in rechargeable battery allows measurement without a mains power supply connection.



Refer to the Surftest **SJ-210/310** Series Brochure (**E15028**) for more details.

MeasurLink® ENABLED Data Management Software by Mitutoyo

Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).

Advanced handheld tester that is easy to operate and meets a variety of needs

- Equipped with a large, touch-screen color graphic LCD for intuitive operation and excellent ease of use.
- Equipped with a high-speed thermal printer (approx. 1.5 times faster than conventional models) as standard, allows for printing of BAC and ADC curves in addition to calculation results (including pass/fail judgments) and assessment profiles. The printer can also print horizontally to match the content displayed on the LCD, and has an easy-to-understand layout.



Refer to the Surftest **SJ-210/310** Series Brochure (**E15028**) for more details.



Optional Accessories for Surftest SJ-210/310

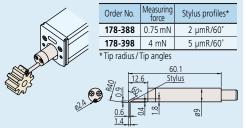
Detector • Small hole detectors Standard detectors Stylus profiles Measuring force Order No. Remarks Order No. Measuring force 178-296 0.75 mN 2 µmR/60° Dedicated to the standard/retractable

178-390 4 mN 5 µmR/90° drive unit 178-387 0.75 mN 2 µmR/60° Dedicated to the 178-386 4 mN 5 µmR/90° drive unit transverse tracing 10 µmR/90° Dedicated to the standard/ retractable drive unit 178-391 4 mN * Tip radius / Tip angles

16.4 Stylus 5 4.8 2.4 59 0 1.5

Gear-tooth surface detectors

Ø







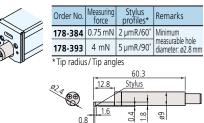






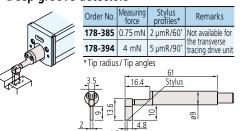
Stylus profiles Remarks 178-383 0.75 mN 2 µmR/60° Minimum measurable hole diameter: ø4.5 mm 5 µmR/90° 178-392 4 mN Tip radius/Tip angles 60.7 16.2 Stylus 4.8 ő

• Extra small hole detectors



Unit: mm

Deep groove detectors



Optional Accessories for Drive Units

•Nosepiece for flat surfaces



Series Not available for the transverse tracing drive unit

7.7 mm

<u>12 mm</u>

12AAA219

Agnetic stand

adapter 12AAA221

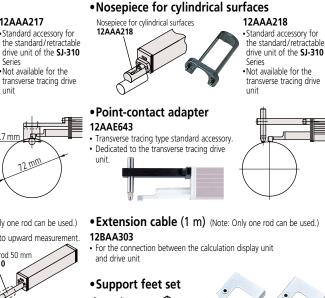
12AAA217

V-type adapter

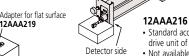
- 12AAE644
- Transverse tracing type standard accessory. · Dedicated to the transverse tracing drive unit.
- Extension rod (50 mm) (Note: Only one rod can be used.) 12AAA210 · Not applicable to upward measurement. Not available for the
- Extension rod 50 mm transverse tracing drive unit (je
- Adapter for flat surface 12AAA219
- Not available for the transverse tracing drive unit

Magnetic stand adapter





Support feet set 12AAA216



· Standard accessory for the standard/retractable drive unit of the SJ-310 Series

· Not available for the transverse tracing drive unit Adjustment range is 28 mm from bottom face.

Height gage adapter



Height gage adapte 12AAA222

tutoy/o

L-4

Surftest

Performs brilliantly in many situations such as in the quality control room, on the factory floor and on the production line.

Surftest SJ-410 SERIES 178 — Compact Surface **Roughness Tester**



MeasurLink[®] ENABLED Data Management Software by Mitutoyo

SPECIFICATIONS

Model No.				SJ-4	11	SJ-412			
Order No.		mm	178-580	-11	178-580-12	178-582-11	178-582-12		
Order No.		inch/mm	178-581	-11	178-581-12	178-583-11	178-583-12		
Measuring X axis				25 mm 50 mm					
range	Z axis (detec		80)0 µm, 80 j	um, 8 µm Up to 2,40		ptional stylus.		
	Detection m	ethod	Differential inductance						
	Resolution		0.01	µm (800 µ	m range), 0.001 µm (8				
Detector		e (Angle/Radius)	60°/2 μ		90°/5 μm	60°/2 µm	90°/5 µm		
Delector	Measuring f		0.75 m	N	4 mN	0.75 mN	4 mN		
	Radius of sk					mm			
	Measuring r					ed (switchable)			
Drive upit Measuring speed						0.5, 1.0 mm/s			
(X axis)	Drive speed					, 5 mm/s			
. ,	Straightness			0.3 µm/2			m/50 mm		
Up/down	Vertical trave					mm			
		ljustment angle				.5°			
Applicable st	andards				1982/JIS 1994/JIS 20				
Deveryon			Ra, Rq, Rz, Ry,	Rp, Rv, Rt, F	3z, Rsk, Rku, Rc, RPc, RS	m, Rmax*1, Rz1max*2, S	S, HSC, RZJIS* ³ , Rppi,		
Parameter			$K \Delta a, K \Delta q, K$ to *4 H to *4 R	IF, KMF, KMF	(c), Rσc, Rk, Rpk, Rvk, M AW, Wx, Wte Customiz	/IFT, IVIFZ, AT, AZ, VO, 🖊	a, лq, Lo, Kpm,		
Filtered profil	0		Primary profile	Roughnoss r	rofile DE profile Wavinos	profile Roughnoss motif r	profile, Waviness motif profile		
Analysis grap					atio curve, Profile hei				
	isation function	nc			la, Hyperbola, Ellipse,				
Filter	isation function	115		101000		5, Gaussian			
	λι					.8, 2.5, 8 mm			
Cutoff value	$\frac{\lambda c}{\lambda s^{*5}}$					25 μm			
Sampling len	715					, 2.5, 8, 25 mm			
Number of in	<u> </u>		x1, x2, x3, x4, x5, x6, x7, x8, x9, x10, x11, x12, x13, x14, x15, x16, x17, x18, x19, x20						
Arbitrary leng			0.1 to 25 mm 0.1 to 50 mm						
Customization				ection of display/evalue					
	-	ur analysis function	Step, Step quantity, Area, Coordinate difference						
		ustment Table) function	Helps to level workpiece prior to skidless measurement						
	Real sampling	g function	Inputs the displacement of the detector while stopping the drive unit						
	statistical pro		Calculates the maximum value, minimum value, average value, standard deviation, pass rate and histogram for each parameter.						
	Judgment ^{*6}				e, 16 % rule, mean valu				
	Storing measur	ement condition	Max. 10 (calculation display unit)						
Calculation display unit	Print functior (Built-in therr		Measurement condition/Calculation result/Judgment result/Calculation result per segment/ Tolerance value/Evaluation curve/Graphic curve/Material ratio curve/Profile height amplitude distribution curve/Environmental setting items/Statistical result (Histogram)						
	Display langu	lage	16 langua	16 languages (Japanese, English, German, French, Italian, Spanish, Portuguese, Korean, Chinese (simplified/traditional), Czech, Polish, Hungarian, Turkish, Swedish, Dutch)					
					ient condition (Up to 10)	UISH, HUNYANAN, LUKIS	n, swealsh, Dulch)		
	Storage func		Memory card (, optional): 50 tatistical dat	0 measurement condition a, 1 backup file of device	setting data, 10 data of Tr	es, 500 display images, 10000 Face 10		
	External I/O f	unctions			/F, Digimatic output,				
Power supply	Battery Charging tim	ne/Endurance	Built-in battery (rechargeable Ni-MH battery)/AC adapter Charging time of the built-in battery: about 4 hours (may vary due to ambient temperature) Endurance: about 1000 measurements (differs slightly due to use conditions/environment)						
1-1- 2	Max. power	consumption				W			
External	Calculation d				275×198	×109 mm			
dimensions	Up/down ind				130.9×6	3×99 mm			
(W×D×H)	Drive unit		1	28×35.8×			5.8×46.6 mm		
	Calculation d	lisplay unit			1.7	' kg			
Mass	Up/down inc	clination unit				kg			
	Drive unit			0.6			64 kg		
Standard Acc	essories		Detector*7/Stanc 178-601 270732 12BAL402 12BAR507 12AAN041	Roughness : Receipt pap	specimen (Ra3 µm) er (Standard type: 5-roll set) leet for the LCD (×1 sheet) ie	AC adapter, Power cable, Fla screwdriver, Hex wrench, Str manual, One-sheet manual,	ap for the touch pen, Operation		

- *1 Calculation is available only when selecting the VDA, ANSI, or JIS 1982 standards.
 *2 Calculation is available only when selecting the ISO 1997 standard. *3 Calculation is available only when selecting the JIS 2001 standard.
 *4 Calculation is available only when selecting the ANSI standard. *5 Not available when selecting the JIS 1982 standard.
 *6 Only the mean value rule is available for the ANSI standard. 16 % rule is not available when selecting the VDA standard.

- *7 Depending on the Order No. of the SJ-410 Series main unit, 178-396 or 178-397 is provided as standard *8 Standard stylus (12AAC731 or 12AAB403) supporting the provided detector is provided as standard.
- L-5





Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).



An inspection certificate is supplied as standard. Refer to page U-11 for details.

Dramatic improvement on compact type surface roughness testers

- Equipped with a large, touch-screen color graphic LCD to achieve both intuitive operation and high operability.
- Skidded and skidless measurement are switchable to perform optimum evaluation according to the measurement setup.
- A wide-range, high-resolution detector and a very accurate drive unit provide superior highaccuracy measurement in its class.
- Detector

Measuring range: 800 µm

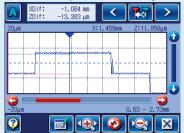
Resolution: 0.0001 µm (when the measuring range is 8 µm)

Drive unit

Straightness/Drive length: 0.3 µm/25 mm (SJ-411) Straightness/Drive length: 0.5 µm/50 mm (SJ-412)

 Simplified contour analysis (Step, Step quantity, Area, Coordinate difference) is available using the point cloud data collected to evaluate the surface roughness.

Allows the evaluation of detailed shapes that cannot be achieved by contour measuring instruments.



- Allows the evaluation of surface roughness in a circumferential direction using the skidless measurement and R-surface compensation functions.
- Conforms to the latest ISO standard and ANSI/ VDA standard in addition to the JIS standard (2001/1994/1982).
- Achieves the performance of a desktop type surface roughness tester in combination with the simplified stand and associated optional accessories.

Optional Accessories for SJ-410 Consumables

- Receipt paper Standard type (5-roll set)
- Receipt paper High-durability paper (5-roll set)
- Protective sheet for the touch panel (×10 sheets)
- Memory card (2 GB)
- 270732 12AAA876 12AAN040 12AAW452



Refer to the Surftest SJ-410 Series Brochure (E15014) for more details.

Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details). MeasurLink' ENABLED



An inspection certificate is supplied as standard. Refer to page U-11 for details.

High precision and high performance type surface roughness tester with a dedicated control unit, offering a userfriendly display and simple operation.

- Equipped with a 7.5-inch, color TFT LCD, color icons and touch panel controls, the display unit is easy to read and simple to operate.
- A built-in joystick on the control unit allows quick and easy positioning. The manual adjustment knob allows fine positioning of a small stylus for measuring small holes.
- In addition to the roughness parameters compliant with ISO/JIS/ANSI/VDA surface roughness standards, contour analysis is also available.



SV-210054

SPECIFICATIONS

JI LONI	c/ tilloitto						
Model No.		SJ-500	SV-2100M4*1	SV-2100S4*1	SV-2100H4*1	SV-2100W4*1	
Stand type		(Optional)* ²	Manual stand	Manual stand Motorized stand			
Measuring	Z1 axis (detector)		800 µm, 80 µm, 8 µm				
range	X axis	50 mm	100 mm				
	X axis	0.05 μm					
Resolution	Z1 axis (detector)	0.01 µm (800 µm), 0.001 µm (80 µm), 0.0001 µm (8 µm)					
	Z2 axis (column)	— — 1 µm					
Assessed pro	ofile	Primary pr	ofile, Roughness profile, Wavi	ness profile, DF profile, Roughr	ness motif profile, Waviness m	otif profile	

*1 While the appearance of the natural stone measuring table varies according to the source, the high stability for which this material is known can always be relied upon. *2 Stand for SJ-500 is optional.



Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).



An inspection certificate is supplied as standard. Refer to page U-11 for details.

A superior data processing tester with PC data analysis for higher efficiency.

Surftest SJ-500P/SV-2100M4 **Data Processing Unit (PC) Surface Roughness Testers**

SJ-500P

MeasurLink[®] ENABLED Data Management Software by Mitutoyo



SV-2100M4 (PC type)

FORMTRACEPAK: Best-selling Surface Roughness Analysis Program

Best-selling dedicated software for surface roughness measurement and analysis. Features a flexible printer format and creation of an original inspection certificate.

CDECIEICATIONIC

SPECIFIC	CATIONS				
Type of data processing unit		PC type			
Model No.		SJ-500P	SV-2100M4* ²		
Elevating shaf	t mechanism of stand	*1	Manual operation only		
Measuring	X axis	50 mm	100 mm		
range	Z1 axis (detector)	800 µm, 80 µm, 8 µm			
Z2-axis (colu	mn) travel range	—	350 mm		
	X axis	0.05 µm			
Resolution	Z1 axis (detector)	0.01 µm (800 µm), 0.001 µn	m (80 μm), 0.0001 μm (8 μm)		
	Z2 axis (column)	_	—		
Applicable standards		JIS 1982/JIS 1994/JIS 2001/ISO 1997/ANSI/VDA			
Assessed profile		Primary profile, Roughness profile, Waviness profile, Filtered waviness profile, Rolling circle waviness profile, Rouling circle center line waviness profile, Envelope residual profile, DIN4776 profile, Roughness motif profile, Waviness motif profile			

*1 The simplified stand or manual column stand is available as an optional accessory. *2 While the appearance of the natural stone measuring table varies according to the source, the high stability for which this material is known can always be relied upon.

L-6



Mitutoyo

Refer to the Surftest SJ-500/SV-2100 Brochure (E15006) for more details.

Surftest

Performs brilliantly in many situations such as in the quality control room, on the factory floor and on the production line.

Surftest Extreme SV-3000CNC/SV-M3000CNC MeasurLink® ENABLED SERIES 178 — CNC Surface Roughness Testers



SV-3000CNC (Inclinable drive unit + Y-axis table)

SV-3000CNC SPECIFICATIONS



Data Management Software by Mitutoyo

(Surface Roughness Tester with built-in Y axis.)

(The pho	oto repi	resents a	special	specification	model.)

Model No.			SV-3000CNC	
	Measuring range		200 mm	
X1 axis (drive unit)	Resolution		0.05 μm	
	Scale type		Reflective-type linear encoder	
	Drive speed	CNC mode	Max. 200 mm/s	
	Drive speed	Joystick mode	0 to 50 mm/s	
	Measuring speed		0.02, 0.05, 0.1, 0.2, 0.5, 1.0, 2.0 mm/s	
	Measuring direction		Backward	
	Straightness		0.5 µm/200 mm	
	Measuring range		200 mm	
	Resolution		0.05 μm	
Y axis (table)	Drive speed	CNC mode	Max. 200 mm/s	
	Drive speed	Joystick mode	0 to 50 mm/s	
	Maximum table loadi	ing	20 kg	
	Travel range	Z2 axis (column, type S)	300 mm	
	llaverlange	Z2 axis (column, type H)	500 mm	
Z2 axis (column)	Resolution		0.05 μm	
	Scale type		Reflective-type linear encoder	
	Drive speed	CNC mode	Max. 200 mm/s	
	Drive speed	Joystick mode	0 to 50 mm/s	
Base unit	Base size (width×dep	oth)	750×600 mm	
Dase unit	Base material		Granite	

Note: While the appearance of the natural stone measuring table varies according to the source, the high stability for which this material is known can always be relied upon.

SV-M3000CNC SPECIFICATIONS

Model No.			SV-M3000CNC		
	Measuring range	ge	200	mm	
	Resolution		0.05	μm	
	Scale type		Reflective-type linear encoder		
X1 axis (drive unit)	Drive speed	CNC mode	Max. 20	0 mm/s	
		Joystick mode 0 to 50 mm/s		mm/s	
	Measuring spe	ed	0.02, 0.05, 0.1, 0.2,	0.5, 1.0, 2.0 mm/s	
	Straightness	When using a standard detector	0.5 µm/	200 mm	
	Measuring rang	je	500	mm	
	Resolution		0.05 μm		
Z2 axis (column)	Scale type		Reflective-type linear encoder		
	Drive speed	CNC mode	Max. 20	0 mm/s	
	Drive speed	Joystick mode	0 to 50 mm/s		
	Measuring range	ge	800 mm		
	Resolution		0.05	μm	
	Scale type		Reflective-type linear encoder		
Y axis	Drive speed	CNC mode	Max. 200 mm/s		
T dXIS	Drive speed	Joystick mode	0 to 50	mm/s	
	Measuring spe	ed	0.02 to	2 mm/s	
	Straightnoss	When using a standard detector holder	Narrow range	0.5 µm/50 mm	
	Straightness	when using a standard detector holder	Wide range	2 µm/800 mm	
	Base size (widt	n×depth)	600×15	00 mm	
Base unit	Base material		Ste	el	
	Maximum table	e loading	300 kg		

L-7





Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).

An inspection certificate is supplied as standard. Refer to page U-11 for details.

- The X1. Y and Z2 axes have a maximum drive speed of 200 mm/s. This permits high-speed positioning that can potentially result in a large increase in the throughput of multiple-profile/multiple-
- workpiece measurement tasks. • Capable of inclined plane measurement through 2 axis simultaneous control in X and Y
- Models equipped with the α axis allow continuous measurement on horizontal and inclined surfaces by power-tilting the X1 axis.
- It is possible to expand the measuring range for multiple workpieces through positioning in Y.
- All connecting cables are contained within the measuring instrument to eliminate any inconvenience during measurement.
- Since the Z1-axis detector incorporates an anti-collision safety device, the detector unit will automatically stop if it touches a workpiece or fixture.
- Surftest Extreme SV-M3000CNC (CNC Surface Roughness Tester with a movable Y-axis table) that handles measurement of large/heavy workpieces, such as engine blocks or crankshafts, is also available.
- Optional external control function (Ext I/O) through bidirectional communication (RS-232C) with the PLC (programmable logic controller) is available.



Refer to the CNC Form Measuring Instrument Series Brochure (E15021) for more details.



MeasurLink' ENABLED

Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).



An inspection certificate is supplied as standard. Refer to page U-11 for details.

Contour Measuring System enabling measurement that is fast, accurate, and easy.

- The operation flow is significantly shortened
- by arranging the controls for stylus position change, measurement start/stop and return on the front of the drive unit.



• Fine and coarse X-axis positioning can be performed easily by using the jog shuttle that covers the whole measuring range.



- The quick-vertical-motion stand allows operators to swiftly and easily move the
- drive unit to and from the measurement height without having to push or pull (only for CV-2100M4).



Quick-vertical-motion stand

 The detector unit (Z1 axis) is equipped with a highly accurate arc scale. This scale directly tracks the arc locus of the stylus tip so that the most accurate compensation can be applied to the scale output, which leads to higher accuracy and resolution. Operators are free from bothersome operations such as measurement magnification switching and calibrating each magnification as required for analog instruments.





Mitutoyo

Refer to the Contracer CV-2100 Series Brochure (E15020) for more details.

Contracer

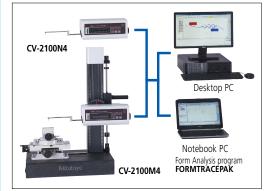
High precision + High-function + High operability = Contracer

Contracer CV-2100

MeasurLink[®] ENABLED Data Management Software by Mitutoyo

SERIES 218 — Contour Measuring Instruments







Optional Column Stand for CV-2100N4

• Allows the use of the CV-2100N4 in a fixed configuration.

218-042

Base material: Granite Inclination range: ±45° Vertical travel: 320 mm Mass: 110 kg Note: While the appearance of the natural stone measuring table varies according to the source, the high stability for which this material is known can always be relied upon.

SPECIFICATIONS

Model No.		CV-2100M4	CV-2100N4		
Measuring	X axis	100 mm			
range	Z1 axis (detector unit)	50 mm			
Z2-axis (column) travel range		350 mm			
X-axis inclinati	ion angle	±45°			
Resolution	X axis	0.1	μm		
1850IULIOII	Z1 axis	0.1 µm			
Drive method	X axis	Motor (0 te	Motor (0 to 20 mm/s)		
Drive method	Vertical travel (Z-axis column)	Manual (Quick-vertical-motion, fine)	—		
Measuring speed		0.02, 0.05, 0.1, 0.2, 0.5, 1.0, 2.0, 5.0 mm/s			
Straightness (when the X axis is horizontal)		2.5 μm/100 mm			
Accuracy	X axis	\pm (2.5+0.02L) µm L = Measurement Length (mm)			
20 °C)	Z1 axis	\pm (2.5+[0.1H]) µm H = Measurementt height from horizontal position within \pm 25 mm			
Measuring dire	ection	Both pulling and pushing directions			
Measuring fac	e direction	Downwar	d direction		
Measuring for	ce	30±10 m	N (3 gf)		
Traceable angle (using the standard stylus)		Ascent 77°, Descent 87° (according to surface property)			
External dimer	nsions (W×D×H)	745×450×885 mm	651×143×138.5 mm		
Mass		145.8 kg	5.8 kg		

1: While the appearance of the natural stone measuring table varies according to the source, the high stability for which this Note material is known can always be relied upon.

Note 2: For the CV-2100N4, a manual column stand (optionally available) or custom fixture is required.



Formtracer

Hybrid machine with dual-role capability

FORMTRACER Avant S3000 Series SERIES 178 — Surface Texture Measuring Instruments





Large sized base models and high-column models are added to the line-up.



MeasurLink[®] ENABLED

Data Management Software by Mitutoyo

Remote box with user-friendly operability



Detector holder (optional)

MeasurLink® ENABLED Data Management Software by Mitutoyo Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).



An inspection certificate is supplied as standard. Refer to page U-11 for details.

- FORMTRACER Avant S3000 Series are highly functional and user-friendly surface roughness measuring systems with innovative design features.
- The FORMTRACER Avant S3000 Series includes models with inclined drive unit. Inclining the drive unit makes it easier to approach target surfaces and measure
- large workpieces.
 Equipped with an operability focused, new style remote box. The new part program key strongly supports mar part-programming.



- High throughput is achieved thanks to high drive speed (X axis: Max. 80 mm/s, Z2 axis: Max. 30 mm/s) and acceleration (X axis: 30
- mm/s²).All connecting cables are contained within the measuring instrument to eliminate any
- inconvenience during measurement.The Z1-axis detector is equipped with a built-in anti-collision safety device.
- A variety of detector holders (optional) are available.
- A detector for measuring contours can be retrofitted.





Refer to the **FORMTRACER Avant** Series Brochure (**E15030**) for more details.

SPECIFICATIONS

Model No. FTA-S4S3000 FTA-H4S3000 FTA-W4S3000 FTA-L4S3000 FTA-S8S3000				FTA-S8S3000	FTA-H8S3000	FTA-W8S3000	FTA-L8S3000		
Measuring	X axis	100 mm			200 mm				
range	Z1 axis	800 µm, 80 µm, 8 µm) µm, 8 µm			
Straightness (when the X ax	s is horizontal)	(0.05+0.001L) μm L = Measurement Length (mm)				(0.1+0.002L) μm L = Measurement Length (mm)			
X-axis inclinat	ion angle			±45° (Only for models with	NX-axis inclining driv	re unit)		
Z2-axis (column) travel range	300 mm	300 mm 500 mm 700 mm		300 mm	500	mm	700 mm	
Base size (W×D)	60×450 mm 1000×450 mm			600×450 mm 1000×450 mm			150 mm	
Base material					Gra	nite			

Note: While the appearance of the natural stone measuring table varies according to the source, the high stability for which this material is known can always be relied upon.

L-9





Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).



An inspection certificate is supplied as standard. Refer to page U-11 for details.

- FORMTRACER Avant C3000 / 4000 Series are highly functional and user-friendly contour measuring systems with innovative design features.
- FORMTRACER Avant C3000/4000 Series comes with

the inclined drive unit as standard, making approach to the target surface and measurement of large workpieces much easier.



- Equipped with an operability focused, new Inclined drive unit style remote box. The new part
- program key strongly supports manual part-programming. • High throughput is achieved thanks to high drive speed
- (X axis: Max. 80 mm/s, Z2 axis: Max. 30 mm/s) and acceleration (X axis: 30 mm/s²). • All connecting cables are contained within the measuring
- instrument to eliminate any inconvenience during measurement.
- The Z1-axis detector is equipped with a built-in anti-collision safety device.
- A detector for measuring contours can be retrofitted.
- The arm of the detector is a user-friendly. magnetic, one-touch, detachable mechanism.
- C4000 type is a highly functional contour measuring

system that has a wide-range digital detector (measuring range: 60 mm), top/ bottom plane continuous measurement function, automatic variable



measuring force function, and stylus drop detection function.



Refer to the FORMTRACER Avant Series Brochure (E15030) for more details SPECIFICATIONS



MeasurLink[®] ENABLED Data Management Software by Mitutoyo

FTA-S4C4000

For C4000



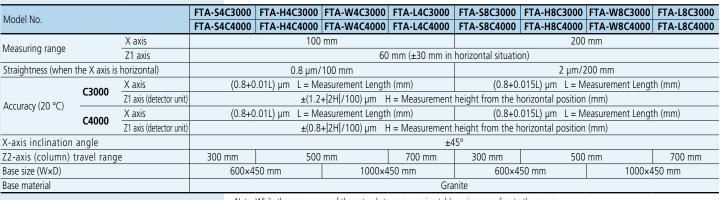


Large sized base models and high-column models are added to the line-up.

Detector

For C3000

/litutoy/0



Note: While the appearance of the natural stone measuring table varies according to the source,

L-10

the high stability for which this material is known can always be relied upon

Formtracer

Hybrid machine with dual-role capability

FORMTRACER Avant D3000/4000 Series SERIES 525 — Surface Texture Measuring Instruments



FTA-S4D3000

(Detector for surface roughness measurement equipped, with monitor arm)

FTA-S4D3000 (Detector for form/contour measurement equipped, with monitor arm)

Large sized base models and high-column models are added to the line-up.

SPECIFICATIONS



Inclined drive unit



Connecting cables are contained within the measuring instrument Remote box with user-friendly operability



For D4000 For D3000

Detector



Refer to the FORMTRACER Avant Series Brochure (E15030) for more details.

FTA-S4D3000 | FTA-H4D3000 | FTA-W4D3000 | FTA-L4D3000 | FTA-S8D3000 | FTA-H8D3000 | FTA-W8D3000 | FTA-L8D3000 Model No. FTA-S4D4000 FTA-H4D4000 FTA-W4D4000 FTA-L4D4000 FTA-S8D4000 FTA-H8D4000 FTA-W8D4000 FTA-L8D4000 Surface roughness measurement 100 mm 200 mm X axis Measuring range Z1 axis 800 µm, 80 µm, 8 µm Straightness (when the X axis is horizontal) (0.05+0.001L) µm L = Measurement Length (mm) (0.1+0.002L) µm L = Measurement Length (mm) **Contour measurement** 100 mm X axis 200 mm Measuring range Z1 axis 60 mm (±30 mm in horizontal situation) Straightness (when the X axis is horizontal) 0.8 µm/100 mm 2 µm/200 mm X axis (0.8+0.01L) µm L = Measurement Length (mm) $(0.8+0.015L) \mu m$ L = Measurement Length (mm) D3000 Z1 axis (detector unit) \pm (1.2+|2H|/100) µm H = Measurement height from the horizontal position (mm) Accuracy (20 °C) (0.8+0.01L) µm L = Measurement Length (mm) (0.8+0.015L) µm L = Measurement Length (mm) X axis D4000 Z1 axis (detector unit) \pm (0.8+[2H]/100) µm H = Measurement height from the horizontal position (mm) **Common specifications** X-axis inclination angle +45Z2-axis (column) travel range 500 mm 700 mm 500 mm 700 mm 300 mm 300 mm Base size (W×D) 600×450 mm 1000×450 mm 1000×450 mm 600×450 mm Base material Granite

Note: While the appearance of the natural stone measuring table varies according to the source, the high stability for which this material is known can always be relied upon.

L-11



Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details). MeasurLink[®] ENABLED



An inspection certificate is supplied as standard. Refer to page U-11 for details.

- FORMTRACER Avant D3000/4000 Series are highly functional and user-friendly surface roughness and contour measuring systems with innovative design features. Both surface roughness measurement and contour measurement are available on a single system just by replacing the detector.
- The contour/roughness detector can be replaced without turning off the controller power and without using any tool. Furthermore, the detector is recognized automatically.
- FORMTRACER Avant D Series comes with the inclined drive unit as standard, making approach to the target surface and measurement of large workpieces much easier.
- Equipped with an operability focused, new style remote box. The new part program key strongly supports manual part-programming.
- High throughput is achieved thanks to high drive speed (X axis: Max. 80 mm/s, Z2 axis: Max. 30 mm/s) and acceleration (X axis: 30 mm/s²).
- All connecting cables are contained within the measuring instrument to eliminate any inconvenience during measurement.
- The Z1-axis detector is equipped with a built-in anti-collision safety device.
- A detector for measuring contours can be retrofitted. • The arm of the detector for contour measurement
- is a magnetic, one-touch, detachable mechanism. • D4000 type is a highly functional contour measuring
- system with a digital detector (measuring range: 60 mm) that enables wide range measurement, top/bottom plane continuous measurement function, automatic variable measuring force function, and stylus drop detection function.

Mitutoyo



Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).



An inspection certificate is supplied as standard. Refer to page U-11 for details.

- CS-3300 Series are highly functional and user-friendly surface roughness and contour measuring systems with innovative design features.
- Large sized base models and high-column models are newly added to the line-up.
- Equipped with a wide range and high resolution Z1-axis detector.
- CS-3300 Series comes with the inclined drive unit as standard, making approach to the target surface and measurement of large workpieces much easier.
- Equipped with an operability focused, new style remote box. The new part program key strongly supports manual part-programming.
- High throughput is achieved thanks to high drive speed (X axis: Max. 80 mm/s, Z2 axis: Max. 30 mm/s).
- All connecting cables are contained within the measuring instrument to eliminate any inconvenience during measurement.
- The Z1-axis detector is equipped with a built-in anti-collision safety device.



MeasurLink[®] ENABLED Data Management Software by Mitutoyo



CS-3300H8

CS-3300H8 (With monitor arm)





SPECIFICATIONS



Inclinable drive unit

Detector sliding mechanism



Connecting cables are contained within the measuring instrument.

Model No.			CS-3300S4	CS-3300H4	CS-3300W4	CS-3300L4	CS-330058	CS-3300H8	CS-3300W8	CS-3300L8
Measuring range X axis			100 mm 200 mm							
	Z1 axis			5 mm (±2.5 mm in horizontal situation)						
Straightness (when the X axis is horizontal)			0.2 μm/100 mm			0.8 µm/200 mm				
Accuracy (20 °C)	X axis		±(0.8+	±(0.8+0.01L) μm L = Measurement Length (mm) (0.8+0.015L) μm L = Measurement Length (:h (mm)			
	Z1 axis (deteo	ctor unit)		±(1.5+ 2H /100) μm H = Measuremen			nt height from the horizontal position (mm)			
	Detection method			Differential inductance						
	Measuring for	orce	0.75 mN							
Detector (Z1 axis)	Stylus tip	Standard		Tip radius 2 μm, Tip angle 60°, Diamond (surface roughness/contour)						
	Stylus tip	Cone	Tip radius 25 µm, Tip angle 30°, Sapphire (contour)							
	Stylus up/down Available (stoppable at mid-stroke if required)									
X-axis inclination an	X-axis inclination angle			±45°						
Z2-axis (column) travel range		300 mm	500	mm	700 mm	300 mm	500	mm	700 mm	
Base size (W×D)			600×4	50 mm	1000×4	50 mm	600×4	50 mm	1000×4	150 mm
Base material						Gra	nite			

Note: While the appearance of the natural stone measuring table varies according to the source, the high stability for which this material is known can always be relied upon.



Formtracer

Hybrid machine with dual-role capability

Formtracer Extreme SV-C4500CNC/SV-C4500CNC HYBRID TYPE1 SERIES 525 — CNC Surface Roughness and **Contour Measuring Systems**





MeasurLink[®] ENABLED

Data Management Software by Mitutoyo

SV-C4500CNC (Contour detector shown mounted together with the inclinable drive unit and Y-axis table)

SV-C4500CNC SPECIFICATIONS

SV-C4500CNC HYBRID TYPE1 (Mounting example of non-contact detector)

Model No.			SV-C4500CNC	
		Measuring range	200 mm	
		Resolution	0.05 µm	
X1 axis		Scale type	Reflective-type linear encoder	
(Drive unit)	Contour	Straightness	2 µm/200 mm	
	Contour	Accuracy (20 °C)	±(0.8+4L/200) μm L: Measuring length (mm)	
	Surface roughness	Straightness	0.5 µm/200 mm	
		Measuring range	60 mm (±30 mm from the horizontal)	
		Resolution	0.02 µm	
Z1 axis	Contour	Scale type	Arc	
(Detector)		Accuracy (20 °C)	±(0.8+ 2H /100) μm H: Measuring height from horizontal position (mm)	
	Surface roughness	Measuring range	800 μm, 80 μm, 8 μm	
	Surface roughness	Resolution	0.01 µm, 0.001 µm, 0.0001 µm	
Z2 axis		Drive range	Specification is selectable from 300 mm or 500 mm.	
(Column)		Resolution	0.05 µm	

Note: While the appearance of the natural stone measuring table varies according to the source, the high stability for which this material is known can always be relied upon.

SV-C4500CNC HYBRID TYPE1 SPECIFICATIONS

Model No.			SV-C4500CNC HYBRID TYPE1		
		Measuring range	200 mm		
		Resolution	0.05 µm		
		Scale type	Reflective-type linear encoder		
X1 axis	Contour	Straightness (20 °C)	2 µm/200 mm		
(Drive unit)	Contour	Accuracy	±(0.8+4L/200) μm L: Measuring length (mm)		
	Surface roughness	Straightness	0.5 µm/200 mm		
	Non-contact type	Straightness	0.5 μm/200 mm		
	Non-contact type	Accuracy	±(0.8+4L/200) μm L: Measuring length (mm)		
		Measuring range	200 mm		
Y axis		Resolution	0.05 μm		
		Maximum table loading	20 kg		
		Measuring range	60 mm (±30 mm from the horizontal)		
	Contour	Resolution	0.02 μm		
		Scale type	Arc		
		Accuracy (20 °C)	±(0.8+ 2H /100) μm H: Measuring height from horizontal position (mm)		
Z1 axis	Surface roughness	Measuring range	800 μm, 80 μm, 8 μm		
	Surface roughiness	Resolution	0.01 μm, 0.001 μm, 0.0001 μm		
	Non-contact type	Measuring range	1.2 mm		
	detector CPS2525*1	Resolution	25 nm		
	Non-contact type	Measuring range	0.1 mm		
	detector CPS0517*1		5 nm		
Z2 axis		Drive range	500 mm		
22 013		Resolution	0.05 µm		

*1 Select either CPS2525 or CPS0517.

Note: While the appearance of the natural stone measuring table varies according to the source, the high stability for which this material is known can always be relied upon.

L-13





Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).

An inspection certificate is supplied as standard Refer to page U-11 for details.

SV-C4500CNC

- High-accuracy stylus type CNC Surface Roughness/Contour Measuring System that allows measurement of surface roughness and form/contour with one unit through detector replacement.
- For models with the α axis, it is possible to perform continuous measurement over horizontal and inclined surfaces by powertilting the X1 axis. In addition, automatic measuring force adjustment function of Z1-axis detector for contour measurement enables automatic measurement with constant measuring force even with the X1-axis tilted.
- For models with the Y-axis table, it is possible to expand the measuring range for multiple workpieces through positioning in the Y-axis direction.
- Since the Z1-axis detector incorporates an anti-collision safety device, the machine will automatically stop if the detector touches a workpiece or jig.
- Optional external control function (Ext I/O) through bidirectional communication (RS-232C) with the PLC (programmable logic controller) is available.

SV-C4500CNC HYBRID TYPE1

- CNC Surface Roughness/Contour Measuring System equipped with a non-contact type detector as well as a contact type surface roughness contour measuring detector.
- Equipped with the Y-axis table, it is possible to expand the measuring range for multiple workpieces through positioning in the Y-axis direction.
- Since the Z1-axis detector incorporates an anti-collision safety device, the machine will automatically stop if the detector touches a workpiece or jig.
- Optional external control function (Ext I/O) through bidirectional communication (RS-232C) with the PLC (programmable logic controller) is available.

Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).



MeasurLink' ENABLED

An inspection certificate is supplied as standard. Refer to page U-11 for details.

- High-accuracy stylus type CNC Surface Measuring System that allows batch measurement of surface roughness and form/contour.
- The X1 and Z2 axes have maximum drive speeds of 40 mm/s and 200 mm/s, respectively. This permits high-speed positioning that can potentially result in a large increase in the throughput of multiple-profile/multiple-workpiece measurement tasks.
- The high resolution linear encoder is incorporated in the X1 and Z1 axes so that high resolution is achieved and batch measurement of form/ contour and surface roughness can be made.
- The active control method is employed for the Z1-axis detector to implement a wide-range measurement capability wherein the variation in dynamic measuring force is restricted.
- Since the Z1-axis detector incorporates an anti-collision safety device, the detector unit will automatically stop if it touches a workpiece or fixture.
- For models with the α axis, it is possible to perform continuous measurement over horizontal and inclined surfaces by power-tilting the X1 axis. (**CS-5000CNC** only) • For models with the Y-axis table, it is possible
- to expand the measuring range for multiple workpieces through positioning in the Y-axis direction.
- Optional external control function (Ext I/O) through bidirectional communication (RS-232C) with the PLC (programmable logic controller) is available.

SPECIFICATIONS

Formtracer Extreme CS-5000CNC/CS-H5000CNC SERIES 525 — CNC Surface Roughness and **Contour Measuring Systems**

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MeasurLink[®] ENABLED

Data Management Software by Mitutoyo





Wide-range detector employing active

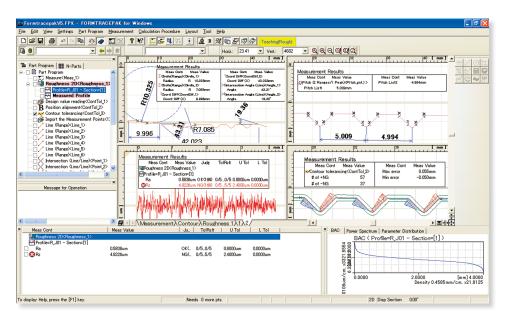
CS-H5000CNC (with Y-axis table)

Model No.			CS-5000CNC	CS-H5000CNC			
	Measuring range		200	mm			
	Resolution		0.00	5 µm			
	Scale type		Transmission-typ	e linear encoder			
	Drive speed	CNC mode	Max. 40	0 mm/s			
(1 axis	Drive speed	Joystick mode	0 to 40) mm/s			
I dxis	Measuring speed		0.02, 0.05, 0.1, 0.2 mm/s (surface roughness), 0.02, 0.05, 0.1, 0.2, 0.5, 1.0, 2.0 mm/s (form/contour				
	Measuring direction		Forward/	backward			
	Straightness	with standard stylus	(0.1+0.0015L) µm L: traverse length (mm)	(0.05+0.0003L) µm L: traverse length (mm)			
	Straightness	with 2X-long stylus	(0.2+0.0015L) µm L: traverse length (mm)	(0.1+0.0015L) µm L: traverse length (mm)			
	Accuracy (20 °C)		±(0.3+0.002L) μm L: traverse length (mm)	±(0.16+0.001L) µm L: traverse length (mm)			
a axis	Inclination range		-45° (CCW), +10° (CW)	—			
	Measuring range	with standard stylus	12				
	ivieasuring range	with 2X-long stylus	24 1	mm			
	Resolution	with standard stylus	0.0008 µm				
	Resolution	with 2X-long stylus	0.001	6 μm			
	Vertical movement of	f the stylus	Arc m	Arc motion			
Scale type Accuracy (20 °C)		Transmission-type linear encoder					
	Accuracy (20 °C)		±(0.3+ 0.02H) μm H: probing height (mm) ±(0.07+ 0.02H) μm H: probing heigh				
1 axis	Measuring force	with standard stylus	4 mN (Fixed)				
Detector)	iviedsuring force	with 2X-long stylus	0.75 mN (Fixed)				
	Traceable angle		Ascent: 60°, Descent: 60° (Depends on the surface texture.)				
		Standard stylus	Tip radius: 5 μm, Tip angle: 40°, Diamond				
		Standard ball stylus	Tip ball radius: 0.				
	Stylus tip shape	2X-long stylus	Tip radius: 5 μm, Tip	angle: 40°, Diamond			
		2X-long stylus	—	Tip radius: 2 µm, Tip angle: 60°, Diamond tip			
		2X-long ball stylus	Tip ball radius: 0.	25 mm, Sapphire			
	Face of stylus		Dowr				
	Travel range	Z2 axis (column, type S)	300				
		Z2 axis (column, type H)	500				
2 axis	Resolution			0.05 μm			
Column)	Scale type		Reflective-type				
	Drive speed	CNC mode	Max. 20				
		Joystick mode	0 to 50				
ase	Base size (W×D)		750×6	00 mm			
130	Base material		Granite				

Formtracer

Hybrid machine with dual-role capability

Surface Roughness/Contour Analysis Program FORMTRACEPAK



• FORMTRACEPAK functions offer total support for controlling the measurement system, surface roughness analysis, contour analysis, contour tolerancing, and inspection report creation.

Editing measurement procedures

The items displayed in the measurement procedure window can be directly modified. You can, for example, perform new analyses by modifying the evaluation setup or roughness standard.

Roughness 200	Changes Evaluation Con
Measured Pi	Charges Roughness Standar
B Posien value read B Position alignment Contour tolerancir B Inport the Measur Chief Bangel/Line	Evaluation Section Settings Data Compensation Settings Data Deletion Data Connection Settings
Line Glange/Line Line Line Glange/Line Line Line Line Glange/Line Line Line	Delete Calculation Intern Calculation

Operation messaging

The operation message window for explaining the next step is incorporated.



Measurement control

To make only a single measurement, you can create a part program in the single mode. To measure multiple workpieces of an identical shape, you can use the teaching mode. Since you can embed the entire flow, from making measurement to printing a report, into a part program, you can efficiently make measurements, analyze data, and output a report. A function is also provided that enables you to insert comments accompanied with photographs at desired timings, enabling you to embed the roles described in a measurement procedure document that

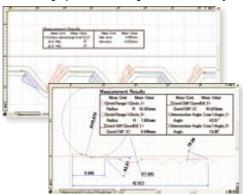
specifies important points such as work settings.

To make immediate measurements, you can use the pull-down menu to easily select and call up the desired operating procedure.



L-15

• Versatile graphics windowing for data and analysis



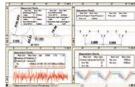
Tab-selection graphics window

Just select a tab to display the measurement data required, such as contour, roughness, or tolerancing results.

Dividing the screen into two or four windows

The screen can be divided into two, or four, windows for the convenient display of measurement data

(for contour and roughness), analysis results, and contour tolerancing data, as required.



Displaying the results in the graphics window

You can paste the graphics obtained from measurements, as well as measurement values (including pass/fail results) and an analysis graph, into the graphics window. This

enables you to check the graphics and measurement results at a glance using the graphics window alone.

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Mitutoyo

Refer to the **FORMTRACEPAK** Brochure (**E15018**) for more details.

litutoyo

Mitutoyo reserves the right to change any or all aspects of any product specification, including prices, designs and service content, without notice

Online help functions

Online help that can be viewed any time is incorporated into the software. In addition to index and keyword searches, a status-saving help button, which displays menus and Windows help with a click of the mouse, is provided.



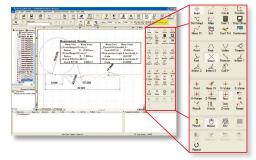
Multiple language support (18 languages)

You can switch the language to be used in the measurement, analysis, and layout windows. After measurements have been made, you can switch to another language and create a report in that language. This function can be used worldwide.

Contour measurement

Contour analysis

A wide variety of commands, which form the basic elements for analysis, are provided, including those for points (10 types), lines (6 types) and circles (6 types). A rich set of commands that combine these elements to calculate angles, pitches and distances as well as performing contour tolerancing and design value generation are also provided as standard features. These functions, combined with the function that enables you to customize the calculation command buttons by hiding less frequently used commands, help you to tailor the window according to the user's environment.



- Contour-tolerancing as a standard feature
- Design value generation
- Data combination
- Simple pitch calculation

Button-editing function

You can hide buttons that are not used frequently. For example, you can choose to display only those buttons that are used frequently and increase the size of the displayed graphics window, thereby customizing the window to suit your needs.

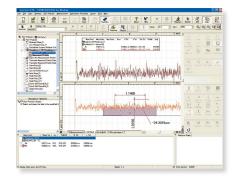


Simple statistical commands

You can perform statistical calculations of roughness parameters and contour analysis results without using a separate program such as Excel.

Surface roughness measurement Surface roughness analysis

FORMTRACEPAK can perform surface roughness analyses that conform to various standards such as ISO, JIS, ANSI and VDA. For comparing measurement values with the tolerance limits, you can use the 16 % rule or the maximum value rule. Furthermore, since FORMTRACEPAK comes with parameter calculation functions as well as a rich set of graphic analysis functions, it can be widely utilized for everything from routine quality control to R&D applications. It also includes many other functions such as the function for eliminating (compensating) shapes, such as slopes and radiused surfaces (R-surfaces), and data deletion.



- Micro contour analysis
- Simple input using drawing symbols
- Multiple-point measurement
- Analysis using multiple-point measurements
- Reference length dialog box
- Analysis condition modification with preview

Mitutoy0

R-surface automatic measurement

Mitutovo Refer to the FORMTRACEPAK Brochure (E15018) for more details.

FORMTRACEPAK

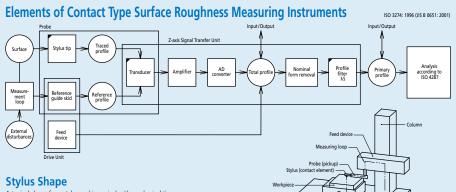


Quick Guide to Precision Measuring Instruments



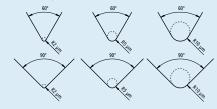
Surftest (Surface Roughness Testers)

ISO 4287: 1997 Geometrical Product Specifications (GPS) – Surface Texture: Profile method– Terms, definitions, and surface texture parameters ISO 4288: 1996 Geometrical Product Specifications (GPS) – Surface Texture: Profile method– Rules and procedures for the assessment of surface texture ISO 3274: 1996 Geometrical Product Specifications (GPS) – Surface Texture: Profile method– Nominal characteristics of contact (stylus) instruments ISO 11562: 1996 Geometrical Product Specifications (GPS) – Surface texture: Profile method– Metrological characteristics of phase correct filters



A typical shape for a stylus end is conical with a spherical tip. Tip radius: f_{tip} = 2 $\mu m,$ 5 μm or 10 μm Cone angle: 60°, 90°

In typical surface roughness testers, the conical angle of the stylus end is 60° unless otherwise specified.



Static Measuring Force

Nominal radius of curvature of stylus tip: µm	Static measuring force at the mean position of stylus: mN	Tolerance on static measuring force variations: mN/µm	
2	0.75	0.035	
5	0.75 (4.0)*1	0.2	
10	0.75 (4.0)	0.2	

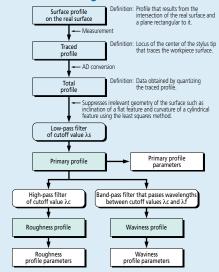
1 The maximum value of static measuring force at the average position of a stylus is to b 4.0 mN for a probe with a special structure including a replaceable stylus.

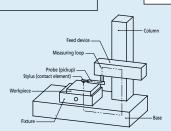
Metrological Characterization of Phase Correct Filters ISO 11562: 1996 (JIS B 0632: 2001)

A profile filter is a phase-correct filter without phase delay (cause of profile distortion dependent on wavelength). The weight function of a phase-correct filter shows a normal (Gaussian) distribution in which the amplitude transmission is 50 % at the cutoff wavelength

Data Processing Flow

Mitutoyo





Relationship between Cutoff Value and Stylus Tip Radius

The following table lists the relationship between the roughness profile cutoff value λc , stylus tip radius Itip, and cutoff ratio $\lambda c/\lambda s$.

λc mm	λs µm	λc/λs	Maximum r _{tip}	Maximum sampling length µm		
0.08	2.5	30	2	0.5		
0.25	2.5	100	2	0.5		
0.8	2.5	300	2 *1	0.5		
2.5	2.5 8 300 5 *2 1.5					
8 25 300 10 12 5						
*1 For a surface with Ra>0.5 µm or Rz>3 µm, a significant error will not usually occur in a measurement even if $E_{\rm p}$ = 5 µm. *2 if a outify the k-k is 7 µm or 8 µm attenuation of the signal due to the mechanical filterion effect						

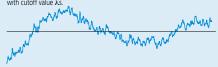
of a pm, attenuation of the signal due to the mechanical intering energy ded tip radius appears outside the roughness profile pass band. Theref s or shape does not affect parameter values calculated from measurem

Surface Profiles



Primary Profile

Profile obtained from the measured profile by applying a low-pass filter with cutoff value λ_s .



Roughness Profile

Profile obtained from the primary profile by suppressing the longer wavelength components using a high-pass filter of cutoff value Ac.

Waviness Profile

Profile obtained by applying a band-pass filter to the primary profile to remove the longer wavelengths above λf and the shorter wavelengths below $\lambda c.$



Roughness sampling length for non-periodic profiles ISO 4288: 1996 (JIS B 0633: 2001)

Table 1: Sampling lengths for aperiodic profile roughness parameters (Ra, Rg, Rsk, Rku, RAq), material ratio curve, probability density function, and related parameters

1						
Ra µm	Sampling length /r mm	Evaluation length In mm				
(0.006) <ra≤0.02 0.02 <ra≤0.1 0.1 <ra≤2 2 <ra≤10 10 <ra≤80< th=""><th>0.08 0.25 0.8 2.5 8</th><th>0.4 1.25 4 12.5 40</th></ra≤80<></ra≤10 </ra≤2 </ra≤0.1 </ra≤0.02 	0.08 0.25 0.8 2.5 8	0.4 1.25 4 12.5 40				

Table 2: Sampling lengths for aperiodic profile roughness

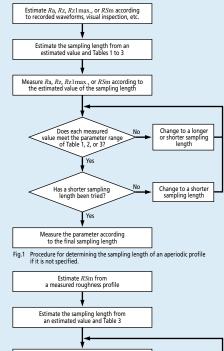
parameters (Rz, Rv, Rp, Rc, Rt)					
Rz Rz1max. µm	Sampling length /r mm	Evaluation length /n mm			
(0.025) <rz, rz1max.≤0.1<br="">0.1 <rz, rz1max.≤0.5<br="">0.5 <rz, rz1max.≤10<br="">10 <rz, rz1max.≤50<br="">50 <rz, rz1max.≤200<="" th=""><th>0.08 0.25 0.8 2.5 8</th><th>0.4 1.25 4 12.5 40</th></rz,></rz,></rz,></rz,></rz,>	0.08 0.25 0.8 2.5 8	0.4 1.25 4 12.5 40			
1) Projection of the programment of Proven Proven Provide And Pt					

Rz is used for measurement of Rz, Rv, Rp, Rc, and Rt.
 Rz1max. only used for measurement of Rz1max., Rv1max., Rp1max., and Rc1max

Table 3: Sampling lengths for measurement of periodic roughness profile roughness parameters and periodic or aperiodic profile parameter *R*sm

Rsm	Sampling length /r	Evaluation length /n
mm	mm	mm
0.013 < <i>R</i> sm≤0.04	0.08	0.4
0.04 < <i>R</i> sm≤0.13	0.25	1.25
0.13 < <i>R</i> sm≤0.4	0.8	4
0.4 < <i>R</i> sm≤1.3	2.5	12.5
1.3 < <i>R</i> sm≤4	8	40

Procedure for determining a sampling length if it is not specified



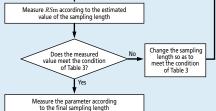
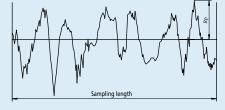


Fig.2 Procedure for determining the sampling length of a periodic profile if it is not specified.

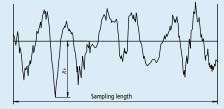
L-17

Definition of Parameters ISO 4287: 1997, Amd. 1: 2009 (JIS B 0261: 2013)

Amplitude Parameters (peak and valley) Maximum peak height of the primary profile P_p Maximum peak height of the roughness profile R_I Maximum peak height of the waviness profile W_p Largest profile peak height Zp within a sampling length



Maximum valley depth of the primary profile P_V Maximum valley depth of the roughness profile R_V Maximum valley depth of the waviness profile W_V Largest profile valley depth Zv within a sampling length

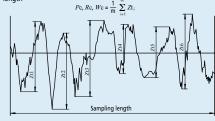


Maximum height of the primary profile PzMaximum height of the roughness profile RzMaximum height of the waviness profile WzSum of height of the largest profile peak height Z_p and the largest profile valley depth $Z_{\rm V}$ within a sampling length

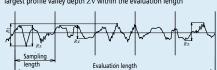


In the old JIS and ISO 4287-1: 1984, *Rz* was used to indicate the "ten point height of irregularities". Care must be taken because differences between results obtained according to the existing and old standards are not always negligibly small. (Be sure to check whether the drawing instructions conform to existing or old standards.)

Mean height of the primary profile elements PcMean height of the roughness profile elements RcMean height of the waviness profile elements WcMean value of the profile element heights Zt within a sampling length



Total height of the primary profile *P*t Total height of the roughness profile *R*t Total height of the waviness profile *W*t Sum of the height of the largest profile peak height Zp and the largest profile valley depth Zv within the evaluation length



Amplitude Parameters (average of ordinates)

Arithmetical mean deviation of the primary profile Pa Arithmetical mean deviation of the roughness profile Ra Arithmetical mean deviation of the waviness profile Wa Arithmetic mean of the absolute ordinate values Z(x) within a sampling length

$$Pa, Ra, Wa = \frac{1}{|} \int_{0}^{1} |Z(\mathbf{x})| d\mathbf{x}$$

with | as *Ip*, *Ir*, or *I*w according to

the case

Root mean square deviation of the primary profile PqRoot mean square deviation of the roughness profile RqRoot mean square deviation of the waviness profile WqRoot mean square value of the ordinate values Z(x) within a sampling length

Pq, Ro

$$Wq = \sqrt{\frac{1}{1}\int_{0}^{1} Z^{2}(x)dx}$$
with | as /p. /r. or /w according to the case

Skewness of the primary profile PskSkewness of the roughness profile RskSkewness of the waviness profile WskQuotient of the mean cube value of the ordinate values Z(x) and the cube of Pq, Rq, or Wq respectively, within a sampling length

$$Rsk = \frac{1}{Rq^3} \left[\frac{1}{lr} \int_{-\infty}^{\infty} Z^3(x) dx \right]$$

The above equation defines Rsk. Psk and Wsk are defined in a similar manner. Psk, Rsk, and Wsk are measures of the asymmetry of the probability density function of the ordinate values.

Kurtosis of the primary profile *P*ku Kurtosis of the roughness profile *R*ku Kurtosis of the waviness profile *W*ku Quotient of the mean quartic value of the ordinate values Z(x) and the fourth power of *Pq*, *Rq*, or *Wq* respectively, within a sampling length sampling length

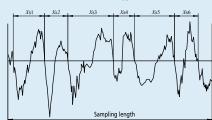
$$Rku = \frac{1}{Rq^4} \left[\frac{1}{lr} \int_0^{lr} Z^4(x) dx \right]$$

The above equation defines $R\mathbf{ku}$. $P\mathbf{ku}$ and $W\mathbf{ku}$ are defined in a similar manner. $P\mathbf{ku}$, $R\mathbf{ku}$, and $W\mathbf{ku}$ are measures of the sharpness of the probability density function of the ordinate values.

Spacing Parameters

Mean width of the primary profile elements PSmMean width of the roughness profile elements RSmMean width of the waviness profile elements WSmMean value of the profile element widths Xs within a sampling length

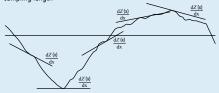
 $PSm, RSm, WSm = \frac{1}{m} \sum_{i=1}^{m} X_{S_i}$



Peak count number based on the primary profile elements PPc Peak count number based on the roughness profile elements RPc Peak count number based on the waviness profile elements WPc $RPc = \frac{1}{RSm}$

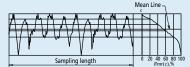
Hybrid Parameters

Root mean square slope of the primary profile $P\Delta q$ Root mean square slope of the roughness profile $R\Delta q$ Root mean square slope of the waviness profile $W\Delta q$ Root mean square value of the ordinate slope dZ/dX within a sampling length



Curves, Probability Density Function, and Related Parameters

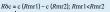
Material ratio curve of the profile (Abbott-Firestone curve) Curve representing the material ratio of the profile as a function of



Material ratio of the primary profile Pmr (c) Material ratio of the roughness profile Rmr (c) Material ratio of the waviness profile Wmr (c) Ratio of the material length of the profile elements M1 (c) at a given level c to the evaluation length

Pmr (c), Rmr (c), Wmr (c) = $\frac{Ml(c)}{ln}$

Section height difference of the primary profile $P\delta c$ Section height difference of the roughness profile $R\delta c$ Section height difference of the waviness profile $W\delta c$ Vertical distance between two section levels of a given material



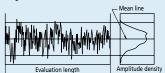


Relative material ratio of the primary profile PmrRelative material ratio of the roughness profile RmrRelative material ratio of the waviness profile WmrMaterial ratio determined at a profile section level $R\delta c$ related to the reference section level c°

> Pmr, Rmr, Wmr = Pmr (c1), Rmr (c1), Wmr (c1) where $c_1 = c_0 - R\delta c (P\delta c, W\delta c)$ $c_0 = c (Pm0, Rmr0, Wmr0)$

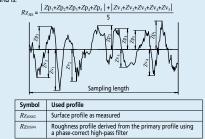
Probability density function (profile height amplitude distribution curve)

Sample probability density function of the ordinate Z(x) within the evaluation length



JIS Specific Parameters

Sum of the absolute mean height of the five highest profile peaks and the absolute mean depth of the five highest profile peaks and the absolute mean depth of the five deepest profile valleys, measured from the mean line within the sampling length of a roughness profile. This profile is obtained from the primary profile using a phase-correct band-pass filter with cutoff values of lc and ls. Ten-point height of irregularities, Rz_{JIS}



Arithmetic mean deviation of the profile Ra75

Arithmetic mean of the absolute values of the profile deviations from the mean line within the sampling length of the roughness profile (75 %). This profile is obtained from a measurement profile using an analog high-pass filter with an attenuation factor of 12db/octave and a cutoff value of λc .

 $Ra_{75} = \frac{1}{\ln} \int_{0}^{\ln} |Z(x)| dx$

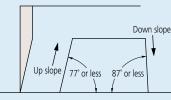


Quick Guide to Precision Measuring Instruments



Contracer (Contour Measuring Instruments)

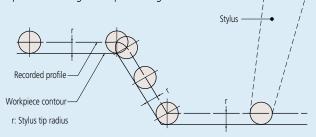
Traceable Angle



The maximum angle at which a stylus can trace upwards or downwards along the contour of a workpiece, in the stylus travel direction, is referred to as the traceable angle. A one-sided sharp stylus with a tip angle of 12° (as in the above figure) can trace a maximum 77° of up slope and a maximum 87° of down slope. For a conical stylus (30° cone), the traceable angle is smaller. An up slope with an angle of 77° or less overall may actually include an angle of more than 77° due to the effect of surface roughness. Surface roughness also affects the measuring force.

Compensating for Stylus Tip Radius

A recorded profile represents the locus of the center of the ball tip rolling on a workpiece surface. (A typical radius is 0.025 mm.) Obviously this is not the same as the true surface profile so, in order to obtain an accurate profile record, it is necessary to compensate for the effect of the tip radius through data processing.

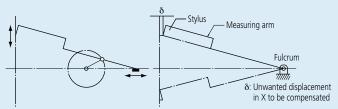


If a profile is read from the recorder through a template or scale, it is necessary to compensate for the stylus tip radius beforehand according to the applied measurement magnification.

Compensating for Arm Rotation

When the stylus traces through a circular-arc, error arises in the X-axis direction of the recorded profile. Possible methods for compensating for this effect are as follows:

- 1) Mechanical compensation
- 2) Electrical compensation



 Software processing. To measure a workpiece contour that involves a large displacement in the vertical direction with high accuracy, one of these compensation methods needs to be implemented.

Accuracy

As the detector units of the X-and Z-axes incorporate scales, the magnification accuracy is displayed not as a percentage but as the linear displacement accuracy for each axis.

Overload Safety Cutout

If an excessive force (overload) is exerted on the stylus tip due, perhaps, to the tip encountering a too-steep slope on a workpiece feature, or a burr, for example, a safety device automatically stops operation and sounds an alarm buzzer. This type of instrument is commonly equipped with separate safety devices for the tracing direction (X axis) load and vertical direction (Z axis) load.

Circular-Arc/Linear Tracing

The locus traced by the stylus tip during vertical stylus movement can be a circular arc or a straight line. Ensuring a straight-line locus entails complex mechanics, while in the case of a circular-arc locus, if the amplitude of stylus displacement is large in the vertical direction, an error (δ) in the recorded profile in the horizontal direction arises. (See figure at lower left)

Z-axis Measurement Methods

Though the X-axis measurement method commonly adopted is by means of a digital scale, the Z-axis measurement divides into analog methods (using a differential transformer, for example) and digital scale methods.

Analog methods vary in Z-axis resolution depending on the measurement magnification and measuring range. Digital scale methods have fixed resolution.

Generally, a digital scale method provides higher accuracy than an analog method.



Contour analysis methods

You can analyze the contour with one of the following two methods after completing the measurement operation.

Data processing section and analysis program

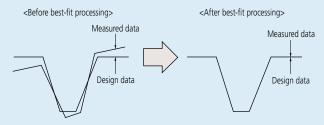
The measured contour is input into the data processing section in real time and a dedicated program performs the analysis using the mouse and/or keyboard. The angle, radius, step, pitch and other data are directly displayed as numerical values. Analysis combining coordinate systems can be easily performed. The graph that goes through stylus radius correction is output to the printer as the recorded profile.

Tolerancing with Design Data

Measured workpiece contour data can be compared with design data in terms of actual and designed shapes rather than just analysis of individual dimensions. In this technique each deviation of the measured contour from the intended contour is displayed and recorded. Also, data from one workpiece example can be processed so as to become the master design data to which other workpieces are compared. This function is particularly useful when the shape of a section greatly affects product performance, or when its shape has an influence on the relationship between mating or assembled parts.

Best-fitting

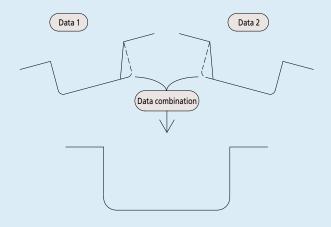
If there is a standard for surface profile data, tolerancing with design data is performed according to the standard. If there is no standard, or if tolerancing only with shape is desired, best-fitting between design data and measurement data can be performed.



The best-fit processing algorithm searches for deviations between both sets of data and derives a coordinate system in which the sum of squares of the deviations is a minimum when the measured data is overlaid on the design data.

Data Combination

Conventionally, if tracing a complete contour is prevented by stylus traceable-angle restrictions then it has to be divided into several sections that are then measured and evaluated separately. This function avoids this undesirable situation by combining the separate sections into one contour by overlaying common elements (lines, points) onto each other. With this function the complete contour can be displayed and various analyses performed in the usual way.



Measurement Examples



Aspheric lens contour



Internal gear teeth



Male thread form



Inner/outer ring contour of a bearing

Female thread form



Gage contour



Roundtest

To realize efficient centering and leveling combined with high-precision measurement

Roundtest RA-10 SERIES 211 — Roundness Measuring



SPECIFICATIONS

Model No. **RA-10** (0.04+6H/10000) µm H: Probing height (mm) Rotational accuracy Radial direction (JIS B 7451-1997) Axial direction (0.04+6X/10000) µm X: distance from the center of rotation (mm) Turntable Maximum probing diameter ø100 mm Maximum loading mass 10 kg Vertical movement Vertical travel 117 mm 75 mm (-25 mm to 50 mm from the rotation center) X axis Travel range ±1000 µm Detector* Measuring range

* Only the standard length stylus is applicable to this detector. The long type cannot be used.

Roundtest RA-120/120P SERIES 211 — Roundness Measuring Instruments



RA-120



The analysis capabilities for the various models (RA-120/120P/10) vary. For details, refer to page L-26.

SPECIFICATIONS

Model No.			RA-120	RA-120P	
	Rotational accuracy Radial direction		(0.04+6H/10000) μm	H: Probing height (mm)	
	(JIS B 7451-1997)	Axial direction	(0.04+6X/10000) µm X: distance from the center of rotation (mm)		
Turntable	Maximum probing diameter*1		ø280 mm (ø380 mm: for the vertical position when detector holder is installed reversely, the maximum probing height is up to 50 mm from the table top.)		
	Maximum loading mass		25 kg		
Vertical movement Vertical travel		280 mm			
X axis Travel range			165 mm (-25 mm to 140 mm from the rotation center)		
Detector *2 Measuring range		±1000 μm			

*1 Auxiliary stage for a low-height workpiece (optional) is required for the measurement 20 mm or less in the radial direction from the center point of the table and 20 mm or less from the table top.

*2 Only the standard length stylus is applicable to this detector. The long type cannot be used.



L-21



MeasurLink[®] ENABLED



MeasurLink[®] ENABLED Data Management Software by Mitutoyo

Position the detector in

contact with the workpiece.

Press the "START/STOP"

button.

MeasurLink[®] ENABLED

Data Management Software by Mitutoyo

Simple measurement procedure

Mount the workpiece on

Press the "Condition

button as required.

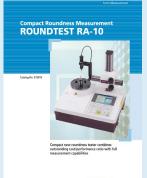
the holding fixture.

Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).

A cost-effective compact instrument that enables full-scale roundness evaluation.

Refer to page U-11 for details.

- Offers easy operation for anyone. A large, simple key arrangement is used.
- User-friendly operation. Measurement results and recorded profiles are easy to view with the large LCD, and can then be printed by the built-in thermal line printer. Furthermore, optional functions to improve usability can be offered.

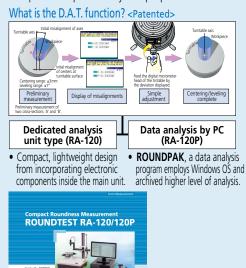


Mitutoyo

Refer to the Roundtest RA-10 Brochure (E15019) for more details.

Easy operation, compact and outstanding cost/performance ratio, designed for use on the shop-floor right beside the production line.

• D.A.T. (Digimatic Adjustment Table) function aids adjustments such as centering and leveling, and substantially reduces the time required for preliminary setup operations.



Mitutoyo

Refer to the Roundtest RA-120/120P

An inspection certificate is supplied as standard.

MeasurLink[®] ENABLED

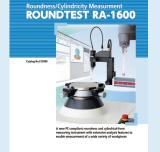
Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).



An inspection certificate is supplied as standard. Refer to page U-11 for details.

- Compact body and a wide measuring range assures precision that compares well with that of higher-grade models.
- D.A.T. (Digital Adjustment Table) function aids manual workpiece centering and leveling.
- Safety mechanism provided in the detection section as a standard feature.
- A sliding mechanism (optional sliding detector holder) can be installed in the detector holder. It enables one-touch measurement of a workpiece with a deep hole having a thick wall, which has been difficult with the standard detector.





Mitutoyo

Refer to the Roundtest RA-1600 Brochure (E15000) for more details.

Achieved the world's highest level of accuracy for this class of machine. A high-performance automatic system equipped with a high-speed automatic centering/leveling function.

- High-speed automatic centering/leveling function contributes to a significant reduction in the man-hours required for setups.
- A fully automatic system which performs processing automatically from part program calling, centering/leveling, measurement, calculation, all the way through to printing.
- Capable of continuous inside/outside diameter measurement without changing the detector orientation (up to 50 mm ID).
- The automatic positioning function of the turntable enables automatic measurement in combination with table rotation and slider/column movement.
- Advanced graphical analysis such as power spectrum chart is available.
- A sliding mechanism is incorporated in the detector holder part. •

Mitutoyo



Refer to the Roundtest RA-2200 Series Brochure (E15001) for more details

Roundtest RA-1600 SERIES 211 — Roundness/Cylindricity

MeasurLink[®] ENABLED

Data Management Software by Mitutoyo

Measuring System





SPECIFICATIONS

Model No.			RA-1600		
	Rotational accuracy	Radial direction	(0.02+6H/10000) µm H: Probing height (mm)		
Turntable	(JIS B 7451-1997)	Axial direction	(0.02+6X/10000) µm X: Distance from the center of rotation (mm)		
Turnlable	Maximum loading mass		25 kg		
	Maximum probing diameter		ø280 mm		
Vertical movement (Z-axis column unit)	Vertical travel		300 mm		
X axis	Travel range		165 mm (–25 mm to +140 mm from the rotation center)		
Detector	Moscuring range	Standard	±400 μm/±40 μm/±4 μm		
Delector	Measuring range	Tracking	±5 mm		

Roundtest RA-2200 SERIES 211 — Roundness/Cylindricity **Measuring System**



System vibration isolator (with side table)

SPECIFICATIONS

Model No.			RA-2200AS	RA-2200DS	RA-2200AH	RA-2200DH	
	Rotational accuracy Radial direction			3.5H/10000) µm			
Turntable	(JIS B 7451-1997)	Axial direction	(0.02+3.5X/10000) µm X: Distance from the center of rotation(mm)				
Turritable	Maximum loading mass		30 kg				
	Maximum probing diameter		ø300 mm				
Vertical movement (Z-axis column unit)			300	300 mm 500 mm		mm	
X axis	Travel range		175 mm (–25 mm to +150 mm from the rotation center)		tion center)		
Detector	Moosuring range	Standard	±400 μm/±40 μm/±4 μm				
Detector	Measuring range Tracking		±5 mm				



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MeasurLink[®] ENABLED Data Management Software by Mitutoyo



RA-2200 AS System vibration isolator (monitor arm type)* * Printer table (provided by the customer) not shown.

Roundtest

To realize efficient centering and leveling combined with high-precision measurement

Measuring System

Roundtest RA-H5200 SERIES 211 — Roundness/Cylindricity



Data Management Software by Mitutoyo



RA-H5200AH with side table

SPECIFICATIONS

Model No.			RA-H5200AS	RA-H5200AH	
	Rotational accuracy	Radial direction	(0.02+3.5H/10000) µm H: Probing height (mm)		
Turntable	(JIS B 7451-1997)	Axial direction	0.02+3.5X/10000) µm X: Distance from the center of rotation (mr		
Turritable	Maximum loading mass		80 kg (On auto-centering: 65 kg)		
	Maximum probing diameter		ø400 mm		
Vertical movement (Z-axis column unit)	Vertical travel		350 mm	550 mm	
X axis	Travel range		225 mm (–25 mm to +200 mm from the rotation center)		
Detector	Measuring range	Standard	±400 μm/±40 μm/±4 μm		
Delector	Inviedsuring fallige	Tracking	±5 mm		

Roundtest Extreme RA-2200 CNC SERIES 211 — CNC Roundness/Cylindricity Measuring System







RA-2200 CNC System vibration isolator (with side table)

RA-2200 CNC

SPECIFICATIONS Model No. Rotational accuracy Radial direction

Dealis Lalins at an			
Radial direction	(0.02+3.5H/10000) µm _H: Probing height (mm)		
Axial direction	(0.02+3.5X/10000) µm X: Distar	nce from the center of rotation (mm)	
ass	30 kg		
iameter	ø256 mm		
	300 mm	500 mm	
	175 mm		
Standard	±400 μm/±40 μm/±4 μm		
Tracking	±5 mm		
	Axial direction ass iameter 5tandard	Axial direction (0.02+3.5X/10000) µm X: Distar ass 30 iameter Ø25 300 mm 175 Standard ±400 µm/±	





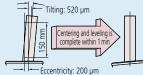
TreasurLink: EXABLED Data Management Software by Mittatyo



An inspection certificate is supplied as standard. Refer to page U-11 for details.

A high-performance automatic system equipped with a high-speed automatic centering / leveling function achieves the world's highest-level of accuracy.

• High-speed automatic centering/leveling function contributes to a significant reduction in the man-hours required for setups.



- A fully automatic system which performs processing automatically from part program calling, centering/leveling, measurement, calculation, all the way through to printing.
- Capable of continuous inside/outside diameter measurement without changing the detector orientation (up to 50 mm ID).
- The automatic positioning function of the turntable enables automatic measurement in combination with table rotation and slider/ column movement.
- Advanced graphical analysis such as a power spectrum chart is available.
- A sliding mechanism is incorporated in the detector holder.
- Highly accurate and easy-to-use turntable. The turntable with automatic centering and leveling function is equipped as standard, which frees operators from manual centering and leveling operations.
- A function to change the detector posture enables CNC automatic measurement. Automatic control of holder arm posture (vertical/horizontal) and the rotation feature of the detector (rotates in 1° increments in the range of 0 to 270°) enables continuous measurement of various feature combinations, such as OD/ID and/or top/ bottom plane measurements.
- A positioning sensor to achieve CNC highaccuracy automatic measurement.
 A Mitutoyo linear scale is used in the X-axis drive unit to directly detect the position of the drive unit. It guarantees the highly precise positioning vital for automatic measurement.
 A roughness detector (optional) is supported.



Refer to the Roundtest **RA-2200** Series Brochure (**E15001**) for more details. MeasurLink' ENABLED

Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).



An inspection certificate is supplied as standard. Refer to page U-11 for details.

Top productivity and performance from a CNC machine with highest-level accuracy.

- The turntable with automatic centering and leveling function is equipped as standard, which frees operators from manual centering and leveling operations.
- Automatic control of holder arm posture (vertical/horizontal) and the rotation feature of the detector (rotates in 1° increments in the range of 0 to 270°) enables continuous measurement of various feature combinations, such as OD/ID and/or top/ bottom plane measurements.
- A Mitutoyo linear scale is used in the X-axis drive unit to directly detect the position of the drive unit. It guarantees the highly precise positioning vital for automatic measurement.
- A roughness detector (optional) is supported.



Mitutoyo

Refer to the Roundtest **RA-H5200** Series Brochure (**E4392**) for more details.

MeasurLink' ENABLED

Products equipped with the measurement data output function can be connected to the measurement data network system MeasurLink (refer to page A-5 for details).

The best accuracy achieved in the class of large cylindricity measuring machine.

- Loading capacity is 350 kg, and the highest rotational accuracy in the class is achieved.
 Besides roundness and cylindricity, the flatness can be measured in high accuracy.
 The workpiece that requires high accuracy measurement such as large and heavy cylindrical parts can be measurement.
- For the ID measurement of a deep hole, such as a main shaft of machine tool, a deep hole measuring unit (specially made, without CNC functions) is available.
- A Mitutoyo linear scale is used in the X-axis drive unit to directly detect the position of the drive unit. It guarantees the highly precise positioning vital for automatic measurement.

Roundtest Extreme RA-H5200 CNC MeasurLink[®] ENABLED SERIES 211 — CNC Roundness/Cylindricity Data Management Software by Mitutoyo Measuring System



RA-H5200 CNC with side table

SPECIFICATIONS

Model No.			RA-H5200 CNC		
Z-axis column unit			Standard column specification (Vertical travel: 350 mm)	High column specification (Vertical travel: 550 mm)	
		Radial direction	(0.02+3.5H/10000) µm H: Probing height (mm)		
Turntable	(JIS B 7451-1997)	Axial direction	(0.02+3.5X/10000) µm X: Distance from the center of rotation (mm		
Turnlable	Maximum loading mass		80 kg (On auto-centering: 65 kg)		
	Maximum probing diameter		ø356 mm		
Vertical movement (Z-axis column unit)			350 mm 550 mm		
X axis	Travel range		225 mm		
Detector	Manguring range	Standard	±400 μm/±40 μm/±4 μm		
Delector	Measuring range	Tracking	±5 mm		

Roundtest Extreme RA-6000 CNC SERIES 211 — CNC Roundness/Cylindricity Measuring System

MeasurLink[®] ENABLED

Data Management Software by Mitutoyo



SPECIFICATIONS

Model No.			RA-6000 CNC		
	Rotational accuracy *1*2	Radial direction	(0.05+6H/10000) μm		
Turntable	(JIS B 7451-1997)	Axial direction	$(0.05+6X/10000) \ \mu m$ X: Distance from the center of rotation (mm)		
Turritable	Maximum loading mass		350 kg		
	Maximum probing diameter		ø880 mm		
Vertical movement (Z-axis column unit)	t) Vertical travel		1050 mm		
X axis	Travel range		465 mm		
Detector	Measuring range	Standard	±400 μm/±40 μm/±4 μm		
Delector	weasuring range	Tracking	±5 mm		

*1 The temperature at which the accuracy can be guaranteed is 20 °C.

*2 The rotational accuracy has been obtained when load is applied to the rotation center.





Roundtest

To realize efficient centering and leveling combined with high-precision measurement

ROUNDPAK Roundness/Cylindricity measurement/Analysis software

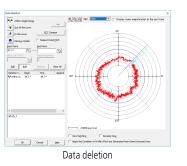
 A wide variety of parameters including those for roundness/ cylindricity, as well as flatness and parallelism,

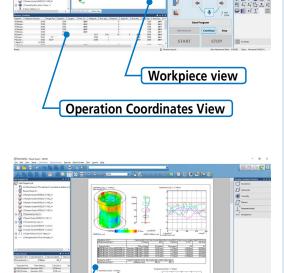


are provided as standard features. You can visually select these parameters using icons. **ROUNDPAK** also comes with specialized functions, such as the design value bestfit analysis function, the harmonic analysis function, and a function for recording the peak or trough points on a circumference. Data that has already been collected can be easily used for re-calculation, or deleted.



Recalculation



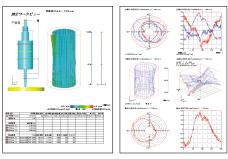


Machine Control View

Part Program List

Icon View

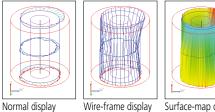
• The customer can create reports in custom formats by specifying how the analysis results will be displayed, as well as the sizes and positions of graphics. The analysis result window can be directly utilized as a layout window. Since the measurement procedure, including the layout information, is saved, the entire process, from measurement start, calculation, result saving, and finally to printing, can be automatically executed.

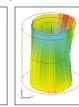


Mitutoyo

• Analysis results such as cylindricity and coaxiality can be visually expressed in 3D graphics.

Result view

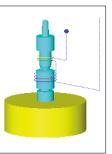






Normal display

- Surface-map display Shading display
- An offline teaching function is provided to create a part program (measurement procedure) without an actual measurement target, enabling the user to virtually execute the measurement operation in a 3D simulation window.





Analysis type	Model	RA-2200/H5200 RA-2200CNC/ H5200CNC/6000CNC	RA-1600	RA-120P	RA-120	RA-10
Roundness	0	1	1	1	1	1
Cylindricity	Þ/	✓	1			
Concentricity	0	1	1	1	1	1
Axis element	\bullet	1	1	√	✓	~
Axis		1	1	1		
Flatness		1	1	✓	1	<i>✓</i>
Parallelism	11	1	1	 Image: A start of the start of	1	
Perpendicularity		1	1	1	1	
Radial deviation	\square	1	1			
Thickness deviation	0	1	1	1	1	
Radial runout	1	1	1	1	1	<i>✓</i>
Total runout	1	\checkmark	1			
Diameter measurement	Φ	\checkmark	1			
Straightness	—	\checkmark	1			
Inclination	L	1	1			
Taper	\wedge	1	1			
Diameter contour tolerancing	\oplus	\checkmark	1			
Rectilinear contour tolerancing	Γ	1	1			
Width measurement (only CNC)		(only CNC)				
Power spectrum	<u>I</u>	1	1			
Harmonic analysis	\oplus	1	1	1		
Profile operation	+	1	1	√		
Tapered surface analysis	8	\checkmark	1			



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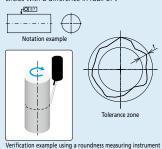
Quick Guide to Precision Measuring Instruments



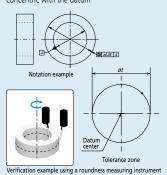
Geometrical tolerances ISO/DIS 1101: 1996*1, ISO 5459*2

ORoundness

Any circumferential line must be contained within the tolerance zone formed between two coplanar circles with a difference in radii of t

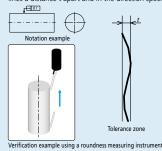


Oconcentricity The center point must be contained within the tolerance zone formed by a circle of diameter t concentric with the datum



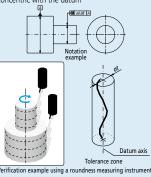
Straightness

Any line on the surface must lie within the tolerance zone formed between two parallel straight lines a distance t apart and in the direction specified



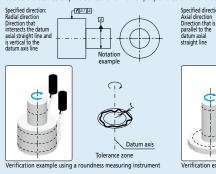
Ocoaxiality

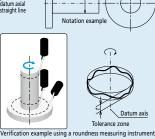
The axis must be contained within the tolerance zone formed by a cylinder of diameter t concentric with the datum



/ Circular Runout (Radial and Axial)

The line must be contained within the tolerance zone formed between two coplanar and/or concentric circles a distance t apart concentric with or perpendicular to the datum





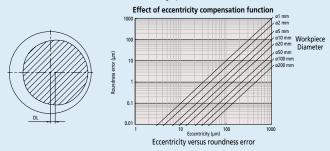
1 0.1 A 4

Adjustment prior to Measurement ISO 4291:1985*3

Centering

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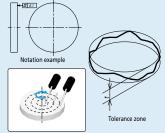
A displacement offset (eccentricity) between the Roundtest's turntable axis and that of the workpiece results in distortion of the measured form (limaçon error) and consequentially produces an error in the calculated roundness value. The larger the eccentricity, the larger is the error in calculated roundness. Therefore the workpiece should be centered (axes made coincident) before measurement. Some roundness testers support accurate measurement with a limacon error correction function. The effectiveness of this function can be seen in the graph below.



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I Flatness

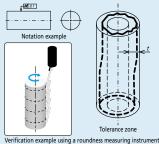
The surface must be contained within the tolerance zone formed between two parallel planes a distance t apart



Cylindricity

1 0.08 A

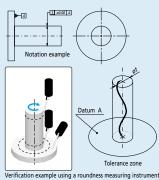
The surface must be contained within the tolerance zone formed between two coaxial cylinders with a difference in radii of t

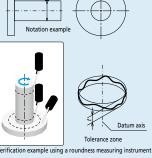


Verification example using a roundness measuring instrument

\perp Perpendicularity

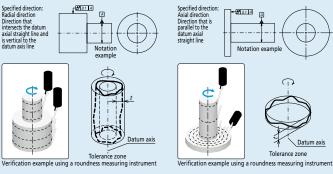
The line or surface must be contained within the tolerance zone formed between two planes a distance t apart and perpendicular to the datum

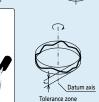




Total Runout (Radial and Axial)

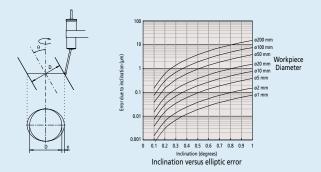
The surface must be contained within the tolerance zone formed between two coaxial cylinders with a difference in radii of t, or planes a distance t apart, concentric with or perpendicular to the datum





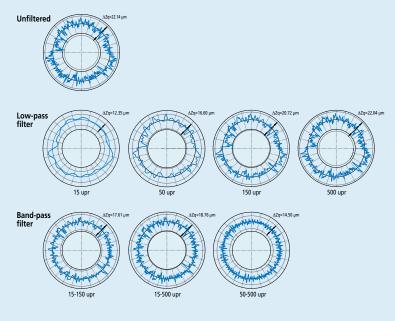
Leveling

Any inclination of the axis of a workpiece with respect to the rotational axis of the measuring instrument will cause an elliptic error. Leveling must be performed so that these axes are sufficiently parallel



Effect of Filter Settings on the Measured Profile ISO 12181-2: 2011*4

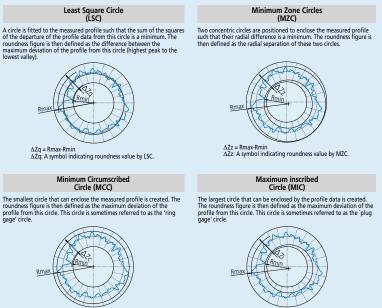
Profiles can be filtered in various ways to reduce or eliminate unwanted detail, with a cut-off value set in terms of undulations per revolution (upr). The effect of different upr settings is shown in the diagrams below, which illustrate how the measured roundness value decreases as lower upr settings progressively smooth out the line.



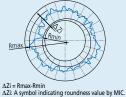
Evaluating the Measured Profile Roundness ISO 12181-1: 2011*5, ISO 4291: 1985*3

Roundness testers use the measurement data to generate reference circles whose dimensions define the roundness value. There are four methods of generating these circles, as shown below, and each method has individual characteristics so the method that best matches the function of the workpiece should be chosen.

Each method results in a different center position for the reference circles and therefore affects the axial location of the circular feature measured



 Δ Zc = Rmax-Rmin Δ Zc: A symbol indicating roundness value by MCC.



Filtering

	2CR filter	Gaussian filter
Standard	ISO 4291: 1985* ³	ISO 12181-1: 2011*5
Attenuation rate	75 %	50 %

Terms and abbreviated terms ISO 12181-1: 2011*5

Abbreviated terms	Terms
LSCI	Least squares reference circle
LSCY	Least squares reference cylinder
LSLI	Least squares reference line
LSPL	Least squares reference plane
LCD	Local cylindricity deviation
LFD	Local flatness deviation
LRD	Local roundness deviation
LSD	Local straightness deviation
MICI	Maximum inscribed reference circle
MICY	Maximum inscribed reference cylinder
MCCI	Minimum circumscribed reference circle
MCCY	Minimum circumscribed reference cylinder
MZCI	Minimum zone reference circles
MZCY	Minimum zone reference cylinder
MZLI	Minimum zone reference lines
MZPL	Minimum zone reference planes
UPR	Undulations per revolution

Parameters and abbreviated terms ISO 12181-1: 2011*5

ALL 1.1		Reference element*			
Abbreviated terms	Parameter	Minimum zone	Least square	Minimum circumscribed	Minimum inscribed
CYLtt	Cylinder taper		1		
STRsg	Generatrix straightness deviation		1		
STRIC	Local generatrix straightness deviation		1		
CYLp	Peak-to-reference cylindricity deviation		1		
FLTp	Peak-to-reference flatness deviation		1		
RONp	Peak-to-reference roundness deviation		1		
STRp	Peak-to-reference straightness deviation		1		
CYLt	Peak-to-valley cylindricity deviation	1	1	1	1
FLTt	Peak-to-valley flatness deviation	1	1		
RONt	Peak-to-valley roundness deviation	1	1	1	1
STRt	Peak-to-valley straightness deviation	1	1		
CYLv	Reference-to-valley cylindricity deviation		1		
FLTv	Reference-to-valley flatness deviation		1		
RONv	Reference-to-valley roundness deviation		1		
STRv	Reference-to-valley straightness deviation		1		
CYLq	Root-mean-square cylindricity deviation		1		
FLTq	Root-mean-squareflatness deviation		1		
RONq	Root-mean-square roundness deviation		1		
STRq	Root-mean-square straightness deviation		1		
STRsa	Straightness deviation of the extracted median line	1	1	1	1

* The reference elements to which the parameter can be applied.

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*1 ISO/DIS 1101: 1996 Geometrical Product Specifications (GPS) - Geometrical tolerancing - Tolerancing of form, orientation, location and run-out

- *2 ISO 5459 Technical drawings Geometrical tolerancing Datums and datum-systems for geometrical tolerances
- *3 ISO 4291: 1985 Methods for the assessment of departure from roundness Measurement of variations in radius
- *4 ISO 12181-2: 2011 Geometrical Product Specifications (GPS) Roundness Part2: Specification operators
- *5 ISO 12181-1: 2011 Geometrical Product Specifications (GPS) Roundness Part 1: Vocabulary and parameters of roundness

